



**INFORMATION DISCLOSURE
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APPLICANT
FORREST et al.

FILING DATE
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2815

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/ PUBLICATION NUMBER	PATENT/ PUBLICATION DATE	NAME	CLASS	SUBCLASS	FILING DATE
EO	4,788,082	November 29, 1988	Schmitt			
EO	5,247,190	September 21, 1993	Friend et al.			
EO	5,256,205	October 26, 1993	Schmitt, III et al.			
EO	5,650,197	July 22, 1997	Halpern			
EO	5,703,436	December 30, 1997	Forrest et al.			
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EO	5,844,363	December 1, 1998	Gu et al.			
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EO	6,087,196	July 11, 2000	Sturm et al.			
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EO	2003/0230980	December 18, 2003	Forrest et al.			

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

OTHER DOCUMENTS

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EO	Jasmin Henry et Al., "Thin-film Amorphous Silicon Position-sensitive Detectors", Adv. Funct. Mater., Vol. 13, No. 12-13 (2001)
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EO		U.S. Patent Application Serial No. 10/233,470 to Shtein et al., Filed September 4, 2002.
EO		U.S. Patent Application Serial No. 09/311,126 to Thompson et al., filed May 13, 1999.

EXAMINER	<i>Calvin D. City</i>	DATE CONSIDERED	9/15/04
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			